

10799836_CLS.txt

Most Frequently Occurring Classifications of Patents Returned
From A Search of 10799836 on January 26, 2005

Original Classifications

2 206/87
2 702/85
2 715/837

Cross-Reference Classifications

2 206/268
2 356/407
2 356/425
2 356/445
2 422/60
2 436/537
2 436/805
2 525/240
2 715/839

Combined classifications

3 715/837
2 206/268
2 206/87
2 356/407
2 356/425
2 356/445
2 422/58
2 422/60
2 435/7.1
2 436/537
2 436/805
2 525/240
2 702/85
2 715/839

10799836_CLSTITLES.txt
Titles of Most Frequently Occurring Classifications of Patents Returned
From A Search of 10799836 on January 26, 2005

- 3 715/837 (2 OR, 1 XR)
Class 715 : DATA PROCESSING: PRESENTATION PROCESSING OF
DOCUMENT
Could not find subclass title.
- 2 206/268 (0 OR, 2 XR)
Class 206 : SPECIAL RECEPTACLE OR PACKAGE
206/242 FOR TOBACCO, PIPE OR CIGARETTE HOLDER
206/265 .With closure
206/268 ..Integral hinge
- 2 206/87 (2 OR, 0 XR)
Class 206 : SPECIAL RECEPTACLE OR PACKAGE
206/85 WITH IGNITER FOR TOBACCO CONTENT
206/87 .Igniter is flint-wick type
- 2 356/407 (0 OR, 2 XR)
Class 356 : OPTICS: MEASURING AND TESTING
356/402 BY SHADE OR COLOR
356/407 .With sample responsive to plural colors
applied simultaneously
- 2 356/425 (0 OR, 2 XR)
Class 356 : OPTICS: MEASURING AND TESTING
356/402 BY SHADE OR COLOR
356/425 .With color determination by light intensity
comparison
- 2 356/445 (0 OR, 2 XR)
Class 356 : OPTICS: MEASURING AND TESTING
356/445 OF LIGHT REFLECTION (E.G., GLASS)
- 2 422/58 (1 OR, 1 XR)
Class 422 : CHEMICAL APPARATUS AND PROCESS DISINFECTION,
DEODORIZING, PRESERVING, OR STERILIZING
422/50 ANALYZER, STRUCTURED INDICATOR, OR MANIPULATIVE
LABORATORY DEVICE
422/55 .Structured visual or optical indicator, per se
422/58 ..In holder or container having special form
- 2 422/60 (0 OR, 2 XR)
Class 422 : CHEMICAL APPARATUS AND PROCESS DISINFECTION,
DEODORIZING, PRESERVING, OR STERILIZING
422/50 ANALYZER, STRUCTURED INDICATOR, OR MANIPULATIVE
LABORATORY DEVICE
422/55 .Structured visual or optical indicator, per se
422/58 ..In holder or container having special form
422/59 ...Column
422/60Having plural-layered material
- 2 435/7.1 (1 OR, 1 XR)
Class 435 : CHEMISTRY: MOLECULAR BIOLOGY AND MICROBIOLOGY
435/4 MEASURING OR TESTING PROCESS INVOLVING ENZYMES
OR MICRO-ORGANISMS; COMPOSITION OR TEST STRIP THEREFORE;
PROCESSES OF FORMING SUCH COMPOSITION OR TEST STRIP

435/7.1 (0 OR, 2 XR) Involving antigen-antibody binding, specific binding protein assay or specific ligand-receptor binding assay

2 436/537 (0 OR, 2 XR)
 Class 436 : CHEMISTRY: ANALYTICAL AND IMMUNOLOGICAL TESTING
 436/536 INVOLVING IMMUNE COMPLEX FORMED IN LIQUID PHASE
 436/537 .Signal modification or steric inhibition

2 436/805 (0 OR, 2 XR)
 Class 436 : CHEMISTRY: ANALYTICAL AND IMMUNOLOGICAL TESTING
 436/805 OPTICAL PROPERTY

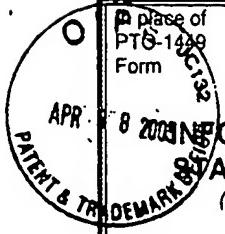
2 525/240 (0 OR, 2 XR)
 Class 525 : SYNTHETIC RESINS OR NATURAL RUBBERS -- PART OF THE CLASS 520 SERIES
 525/50 .MIXING OF TWO OR MORE SOLID POLYMERS; MIXING OF SOLID POLYMER OR SICP WITH SICP OR SPF1; MIXING OF SICP WITH AN ETHYLENIC AGENT; MIXING OF SOLID POLYMER WITH A CHEMICAL TREATING OR ETHYLENIC AGENT; OR PROCESSES OF FORMING OR REACTING; OR THE RESULTANT PRODUCT OF ANY OF THE

reactants
 chemical
 any

525/55 ..At least one solid polymer derived from ethylenic reactants only
 525/191 ...Polymer mixture of two or more solid polymers derived from ethylenically unsaturated only; or mixtures of said polymer mixture with a treating agent; or products or processes of preparing of the above mixtures
 525/240Solid polymer derived from ethylene or propylene

2 702/85 (2 OR, 0 XR)
 Class 702 : DATA PROCESSING: MEASURING, CALIBRATING, OR TESTING
 702/85 CALIBRATION OR CORRECTION SYSTEM

2 715/839 (0 OR, 2 XR)
 Class 715 : DATA PROCESSING: PRESENTATION PROCESSING OF DOCUMENT
 Could not find subclass title.



<input checked="" type="checkbox"/> place of PTO-1449 Form		U. S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		Complete if Known	
 INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(use as many sheets as necessary)</i>		Application Number 10/799,836 Filing Date 03/12/2004 Applicant(s) Saini et al. Art Unit 2879 Examiner Name To be Assigned Attorney Docket Number 34003.110			
SHEET	1	OF	1		

NON-PATENT LITERATURE DOCUMENTS		
Examiner's Initials	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article, title of the item, date, page(s), volume-issue number(s), publisher, city/country where published
	AK	Muray et al., "Advances in Arrayed Microcolumn Lithography", Journal of Vacuum Science and Technology. B, Microelectronics and Nanometer Structures Processing, Measurement and Phenomena: An Official Publication of the American Vacuum Society, Volume 18 (6), November/December 2000, pages 3099-3104. (IRN10495228)

Examiner Signature		Date Considered	
-----------------------	--	--------------------	--

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include a copy of this form with next communication to applicant.

In place of PTO-1449 Form	U. S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE			Complete if Known	
<p style="text-align: center;">O I P E INFORMATION DISCLOSURE STATEMENT BY APPLICANT <small>(use as many sheets as necessary)</small></p> <p style="text-align: right;">DEC 23 2004</p> <p style="text-align: right;">PATENT</p>			Application Number	10/799,836	
			Filing Date	March 12, 2004	
			Applicant(s)	Rahul Saini et al.	
			Art Unit	2879	
			Examiner Name	Unknown	
SHEET	1	OF	1	Attorney Docket Number	34003.110

U. S. PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS

FOREIGN PATENT DOCUMENTS					
Examiner's Initials	Cite No.	Foreign Patent Document (Country Code - Number - Kind)	Publication Date MM-DD-YYYY	Patentee or Applicant of Cited Document	Translation Y/N

NON-PATENT LITERATURE DOCUMENTS

Examiner's Initials	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article, title of the item, date, page(s), volume-issue number(s), publisher, city/country where published
	A3	Dechev et al., "Microassembly of 3-D Microstructure Using a Compliant, Passive Microgripper," Journal of Microelectromechanical Systems, Vol. 13, No. 2, April 2004, pages 176-189.
	A4	Tsui et al., "Micromachined end-effector and techniques for directed MEMS assembly," Journal of Micromechanics and Microengineering, Institute of Physics Publishing, United Kingdom 2004, pages 1-8.
	A5	Ellis, et al., "High aspect ratio silicon micromechanical connectors", High Aspect Ratio Micro-Structure Technology Workshop, June 15-17, 2003, Monterey, California USA.
	A6	M. Szilagyi et al., "Synthesis of Electrostatic Focusing and Deflection Systems", JVST B 15(6), Nov/Dec 1997, pp 1971

Examiner Signature		Date Considered	
--------------------	--	-----------------	--

EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include a copy of this form with next communication to applicant.